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APPLICANTS

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** CONTINUING DATA ***** None & W. &

** FOREIGN APPLICATIONS ***** & W. &
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IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged <u>& W. &</u> Examiner's Signature Initials	JAPAN	9	35	3

ADDRESS

23373
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11-17-04
TITLE Method for Semiconductor Device Manufacturing to Include
MultiStage Chemical Vapor Deposition of Material Oxide Film
~~Method for manufacturing semiconductor device~~

FILING FEE RECEIVED 1020	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit _____
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